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CAPACITOR ON THE SEMICONDUCTOR WAFER

Appl. No. : 10/709,846 Confirmation No. 3845
Applicant : Ching-Huei Tsai
Filed : June 1, 2004
TC/A.U. : 2811
Examiner : Owens, Douglas W
Docket No. : NAUP0572USA
Customer No. : 27765

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Subject: Request for Continued Examination (RCE) in response to the
Office action dated 04/06/2006

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INTRODUCTORY COMMENTS

Dear Sir:

10 In response to the Office action of April 6, 2006, the above-identified
application is to be amended as indicated in the following section.

Amendment to the claims are reflected in the listing of claims which
begins on page 2 of this paper.

15 Remarks/Arguments begin on page 5 of this paper.